



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815

Examiner: Jose R. Diaz

Serial No.:

09/737,642

Filed: December 14, 2000

In re Application of: Daniel C. Wang

: METAL-TO-METAL ANTIFUSE STRUCTURE AND FABRICATION

METHOD

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed Mail Stop RCE, Commissioner for

Patents, P.D. Box 1450, Alexandria, VA 22313-1450, on October 29, 2003,

Stephanie Davis

AMENDMENT

Mail Stop: RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The following is being submitted in response to the Final Office Action dated September 9, 2003 and filed concurrently with a Request for Continued Examination (RCE). Please amend the application as follows: